



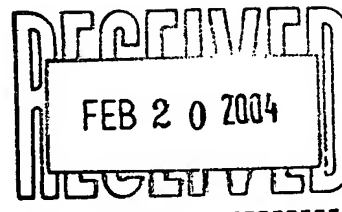
Application No. 10/054,259
Amendment dated February 10, 2004
Reply to Office action of September 12, 2003

1756

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/054,259 — Confirmation No. 7049
Applicant : Ronald M. Kubacki
Filed : January 22, 2002
TC/A.U. : Art Unit 1756
Examiner : Nicole M. Barreca
Docket No. : 02-103
Customer No. : 24026
Title : Capacitor with Plasma Deposited Dielectric



AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

To the Honorable Commissioner for Patents:

This amendment is in response to the Office action dated September 12, 2003, and is being filed within two months after the three-month shortened statutory period set forth in the Office action (February 12, 2004). Enclosed is a check in the amount of \$210.00 for extension for response within two months.

Amendments to the Claims are reflected in the listing of claims, which begin on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.

CERTIFICATE OF MAILING UNDER 37 CFR 1.8(a)

I hereby certify that this paper, along with any paper referred to as being attached or enclosed, is being deposited with the United States Postal Service on the date indicated below, with sufficient postage, as first class mail, in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Signature

Printed Name

Date

Philip O. Post
PHILIP O. POST
10 FEBRUARY 2004

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